

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,882,407 B2
DATED : April 19, 2005
INVENTOR(S) : Tadahiro Asaishi

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 1,

Lines 5-9, should be deleted and the following inserted therefor:

-- The present invention relates to an exposure apparatus suitable for manufacturing a device typified by, e.g., a semiconductor device or liquid crystal display device. --.

Line 13, "apparatus" should read -- apparatus, --.

Column 7,

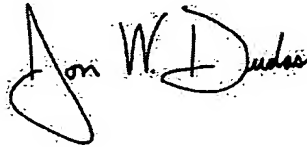
Line 20, "conformity" should read -- uniformity --.

Line 27, "hundres" should read -- hundreds --.

Line 59, "integarated" should read -- integrated --.

Signed and Sealed this

Fourth Day of October, 2005

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a distinct "D".

JON W. DUDAS
Director of the United States Patent and Trademark Office